



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: VIRBULIS ET AL - 1

SERIAL NO.: 10/053,446

GROUP: 1765

FILED: JANUARY 17, 2002

FOR: PROCESS AND APPARATUS FOR PRODUCING A SILICON SINGLE CRYSTAL

RECEIVED  
APR 23 2002  
TC 1700

SUBMISSION OF INFORMATION DISCLOSURE STATEMENT  
OF DR. WOLFGANG STAUDACHER

BOX NON-FEE AMENDMENT  
Assistant Commissioner of Patents  
Washington, D.C. 20231

RECEIVED  
APR 9 - 2002  
TC 1700

Dear Sir:

Applicants wish to bring to the attention of the Patent Examiner the attached Information Disclosure Statement, duly signed by Dr. Wolfgang Staudacher, the Office Action of the German Patent and Trademark Office, and the three (3) references listed on the enclosed Form PTO-1449 and attached thereto.

The relevance of these references is that they are cited in the Specification and in the Office Action of the German Patent and Trademark Office, and may be material to the examination of the application.

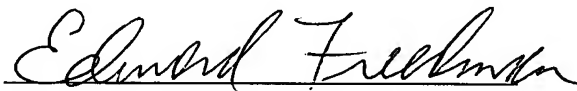
Since this Information Disclosure Statement is being filed

prior to a first Office Action, it is believed that no fee is due. However, if it is determined that a fee is due, the Commissioner is hereby authorized to charge, or to credit any over payment, to our Deposit Account Number 03-2468.

It is respectfully requested that this Information Disclosure Statement be considered and placed into the application file.

Respectfully submitted,

VIRBULIS ET AL- 1



Allison C. Collard, Reg. No. 22,532  
Edward R. Freedman, Reg. No. 26,048  
Attorneys for Applicant

COLLARD & ROE, P.C.  
1077 Northern Boulevard  
Roslyn, New York 11576  
(516) 365-9802

Erf/mt

Papers Sent:

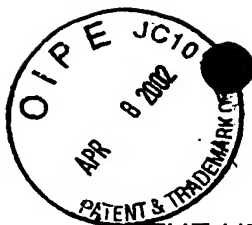
Preliminary Amendment

Enclosures:

- (1) Revised FIG. 4;
- (2) Submission of Information Disclosure Statement of Dr. Wolfgang Staudacher;
- (3) Information Disclosure Statement of Dr. Wolfgang Staudacher;
- (4) Office Action of the German Patent and Trademark Office;
- (5) PTO-form 1449 w/copies of three (3) references.

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Assistant Commissioner of Patents, Washington, D.C. 20231, on April 3, 2002.

  
Lisa L. Vulpis



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

VIRBULIS ET AL.-1

Serial Number: 10/053,446

Group Art Unit: 1765

Filed: January 17, 2002

For: PROCESS AND APPARATUS FOR PRODUCING A SILICON SINGLE CRYSTAL

#6  
5-14-02  
RECEIVED  
APR 23 2002  
TC 1700

Information Disclosure Statement

Honorable Commissioner of Patents and Trademarks  
Washington, D.C. 20231

RECEIVED

APR 9 - 2002

TC 1700

Sir or Madam:

I, Wolfgang Staudacher, associated with the preparation and prosecution of the above-identified application, residing at Seebauerstraße 4, 81735 München, Germany, wish to call the attention of the Patent Examiner to the references enumerated on the enclosed PTO Form-1449.

I believe the documents enumerated on the enclosed Form PTO-1449 and attached thereto, are cited in the enclosed application and in the Office Action of the German Patent and Trademark Office and may be material to the examination of the application.

Therefore, it is respectfully requested that the foregoing Information Disclosure Statement be considered by the Examiner and incorporated into the file of this application.

I wish to comment as follows concerning the prior art references enumerated on PTO Form-1449:

GB 1 347 108 is already in English language.

For DE 37 01 733 an English Derwent Abstract is enclosed.

Signed this 13<sup>th</sup> day of March, 2002.

  
.....  
Dr. Wolfgang Staudacher